

*A method to determine coating's  
Young's modulus from frequency  
shift of silicon cantilevers*

Riccardo DeSalvo, Innocenzo Pinto

Wave group, University of Sannio at Benevento, Italy

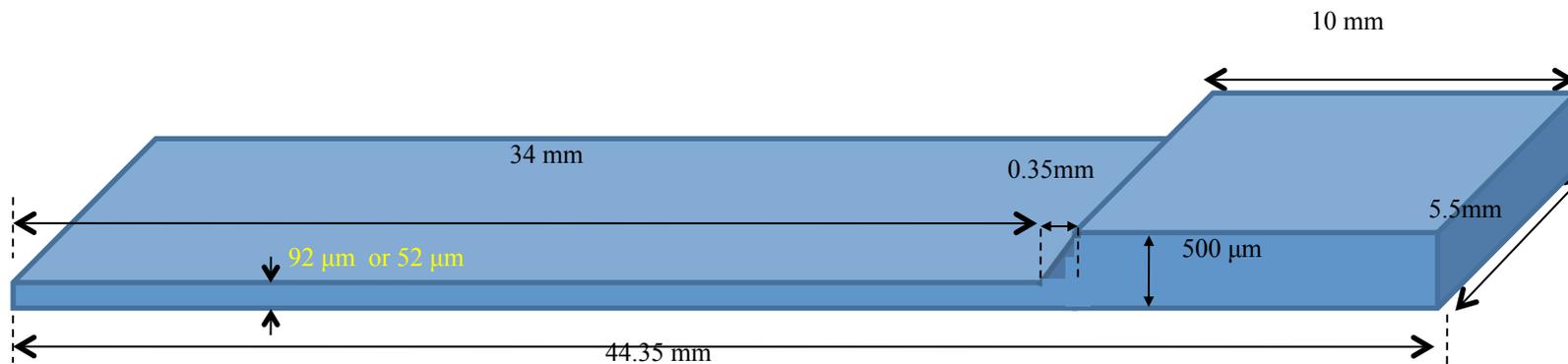
Shiuh Chao, Jeng-shiun Ou, Vincent Huang, Julie  
Wang, Steve Wang, Howard Pan, Chia-Wei Lee  
National Tsing Hua University, Taiwan

# *The physical effect*

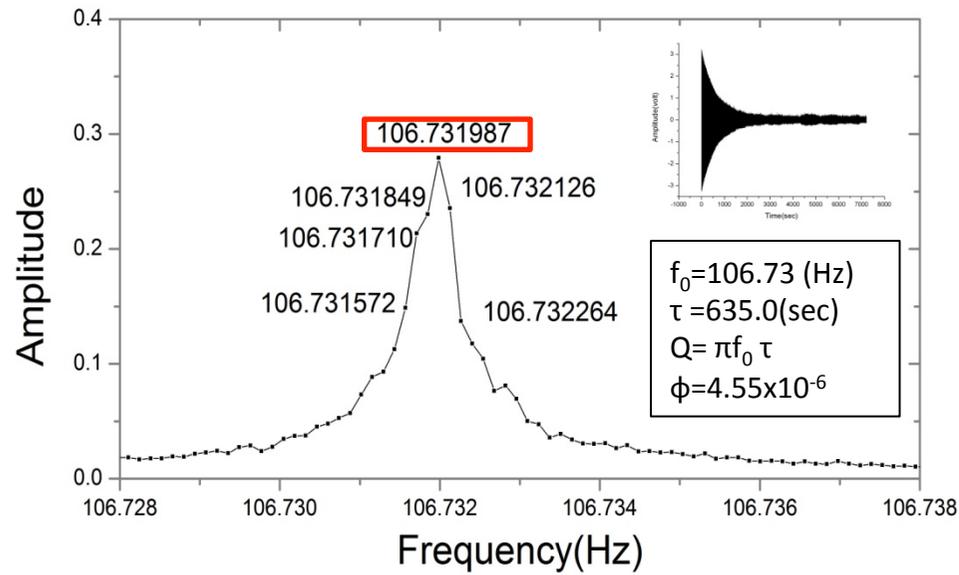
- Adding a coating makes a cantilever stiffer
- Resonant frequency moves up in frequency
- Comparing the frequency shift measured with a Finite Element Model one can allow us to extract the coating Young's modulus

# The enabler

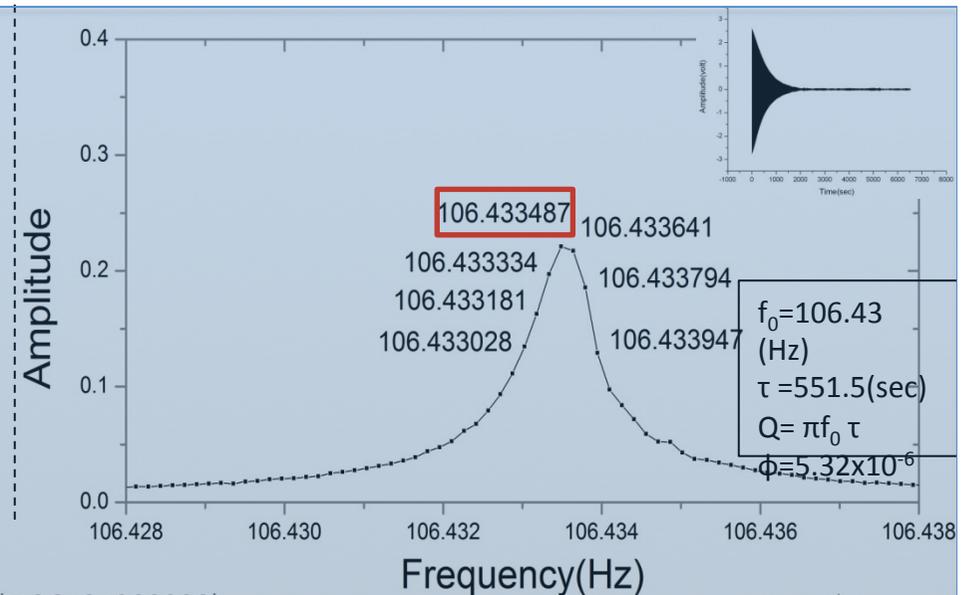
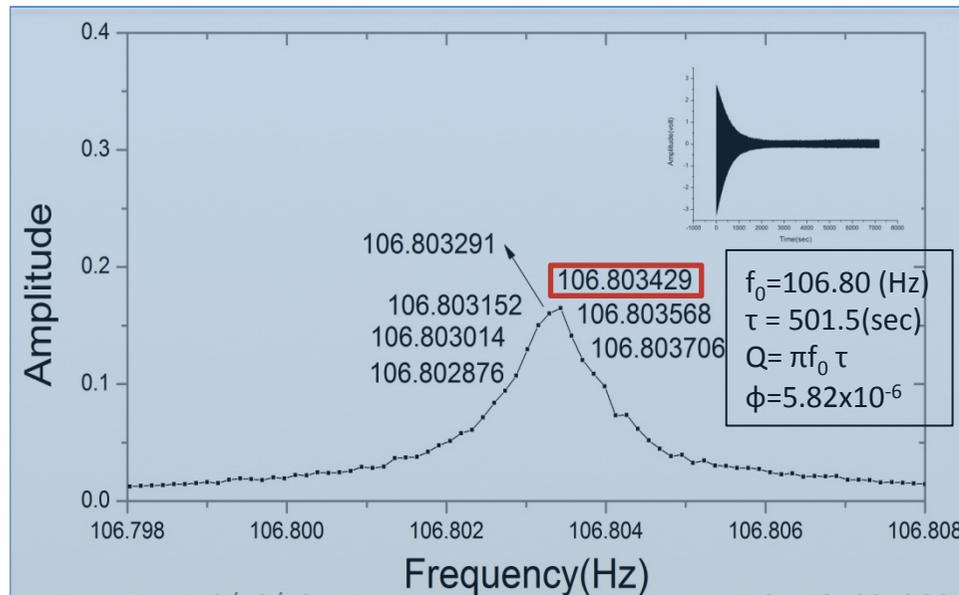
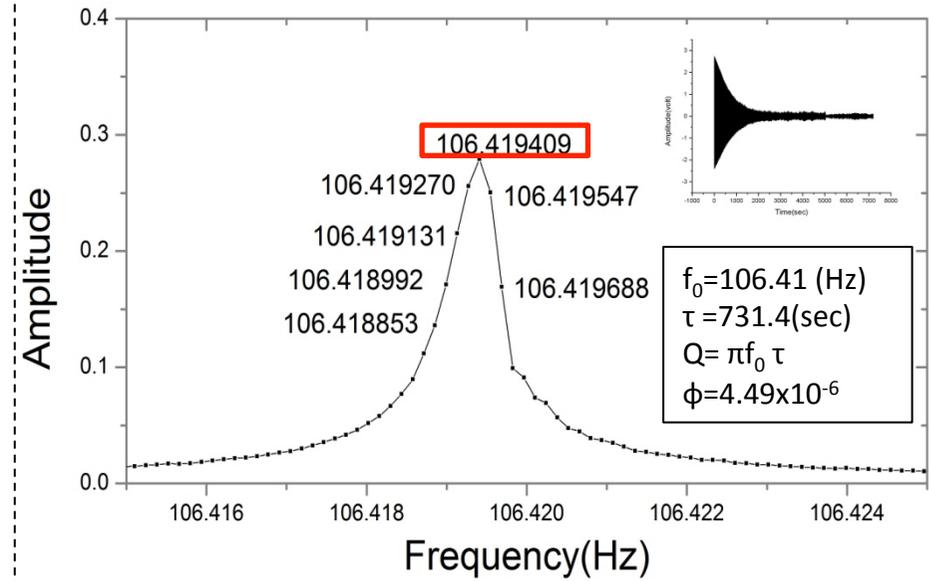
- Thick holding pad reduces re-clamping error and produce high measurement precision



Frequency of silicon cantilever substrate  
And with 3 nano-layers coated



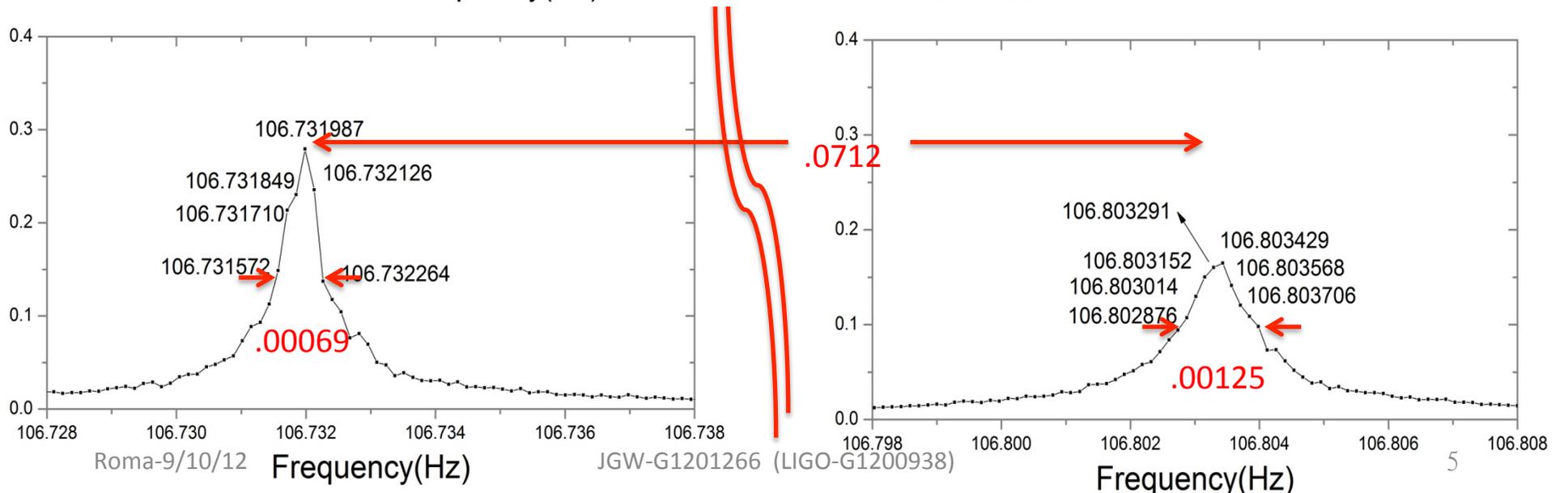
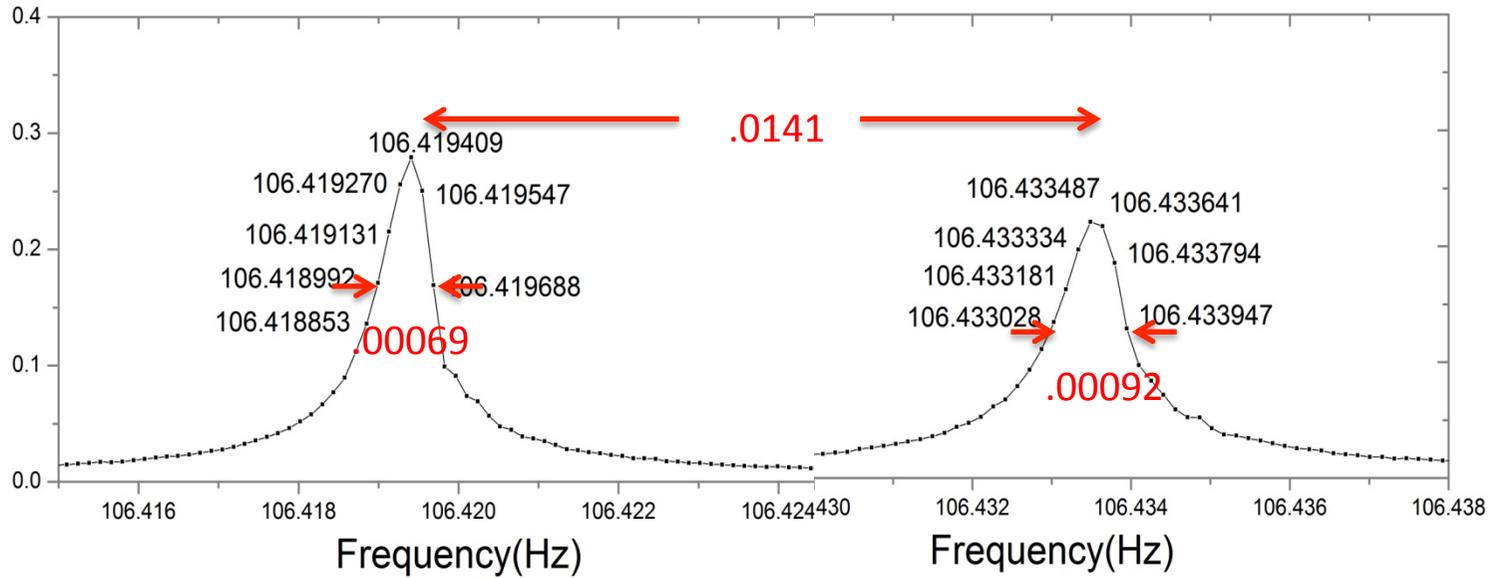
Frequency of silicon cantilever substrate  
And with 19 nano-layers coated



Can measure the frequency shift caused by coating with precision  $< 10^{-3}$

Thermal frequency shifts likely dominate

MUST measure temperature to measure thermal shift



# Thermal effects

$$f \propto \sqrt{Y}$$

- $\partial Y / \partial T = 127 \times 10^{-6} / ^\circ\text{C}$
- Thermal shift  $\partial f / \partial T \sim 50 \times 10^{-6} / ^\circ\text{C}$
- Measured  $\Delta f \sim 100-600 \times 10^{-6}$
- Temperature affects the result

# Question 1

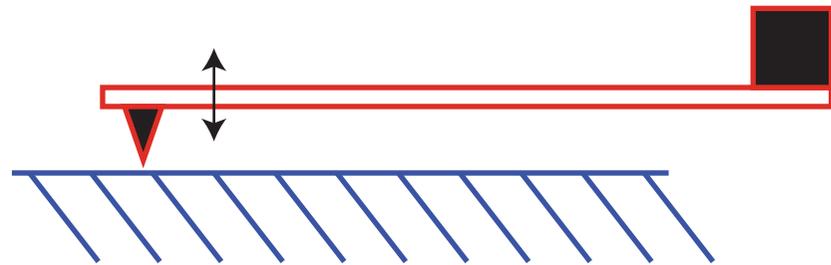
- Will the sensitivity be enough?
- Frequency measurements at  $10^{-6}$ , OK
- Simultaneous measurements over several higher mode resonant frequencies will increase the sensitivity

## Question 2

- Is this the desired Young's Modulus?
- This measurement extracts the parallel Young's Modulus
- Coating thermal noise requires the perpendicular Young's Modulus

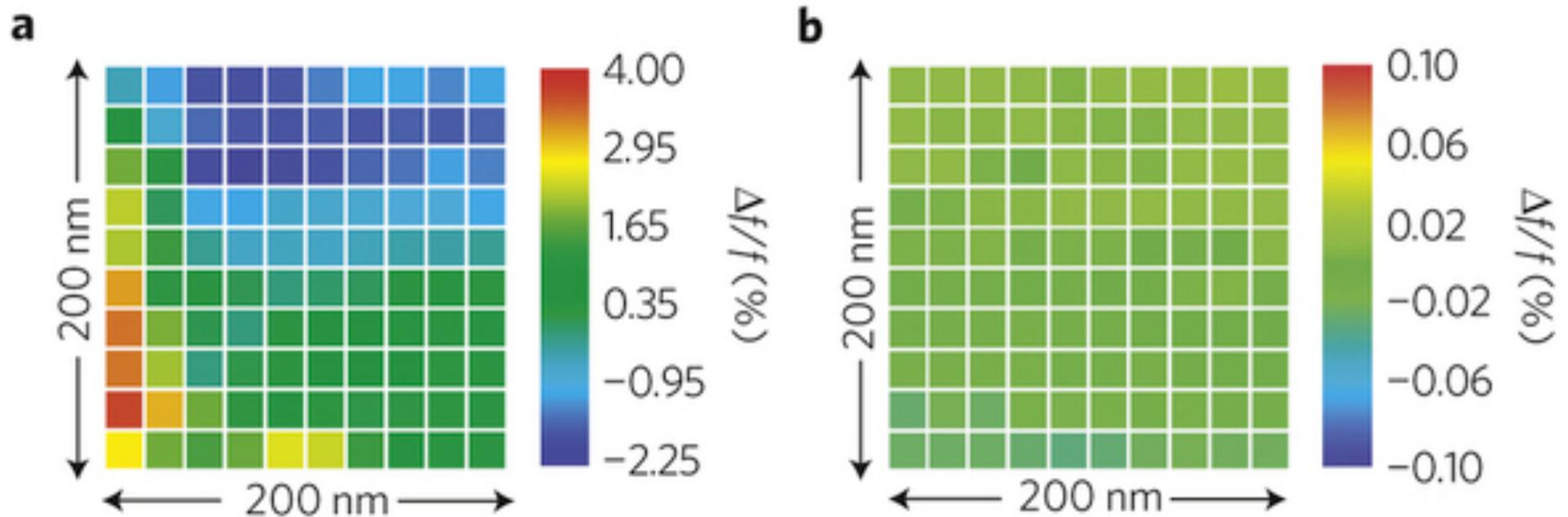
# How to measure the // Young's Modulus

- Konrad Samwer uses a modified Atomic Force Acoustic Microscope to **measure the local elasticity with a no-indentation method**
- The **atomic force microscope needle is brought in contact, in the elastic regime**
- From the variation of resonant frequency of the needle's cantilever the **local Young's modulus of the material is measured**



Local elastic properties of a metallic glass Hannes Wagner, Dennis Bedorf, Stefan Küchemann, Moritz Schwabe, Bo Zhang, Walter Arnold & Konrad Samwer *Nature Materials* 10, 439–442 (2011)  
And supplemental material

# Typical AFAM scan



- **a**, Map of the local contact-resonance frequencies on amorphous glass. **b**, on crystal. Both maps represent the results of AFAM data at 100 different positions on the samples surfaces

# *Good and bad*

- Samwer's technique only measures Young's modulus over the first nanometer depth
- A mixture of parallel and perpendicular Young's modulus is measured
- The perpendicular Young's modulus can be disentangled with the cantilever frequency shift information